

IN THE U. S. PATENT AND TRADEMARK OFFICE

RECEIPT

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5-31-01

In re Application of: MESCHER, et al.)
Serial Number: 09/712,082) Examiner: MONROE, B.
Filed: 11/13/2000) Group Art Unit: 2121
For: LITHOGRAPHY PROCESS FOR)
PATTERNING HGI₂ PHOTONIC DEVICES)
Attorney Docket Number: SD-8310)

RECEIVED

MAY 24 2001

Assistant Commissioner for Patents
Office of Initial Patent Examination
Customer Service Center
Washington, D. C. 20231

Technology Center 2100

REQUEST FOR CORRECTION OF FILING RECEIPT

Sir:

Applicant requests CORRECTION of the USPTO Filing Receipt in application
09/712,082.

Please correct the spelling of the place of residence for Mark. J. Mescher to read
Auburndale, MA.

Also, the name and the residence of the third Applicant, Hail Hermon, were
misspelled on the Filing Receipt. The correct spelling of Applicant's name is Haim Hermon.
The correct spelling of his place of residence is Jerusalem, ISRAEL.

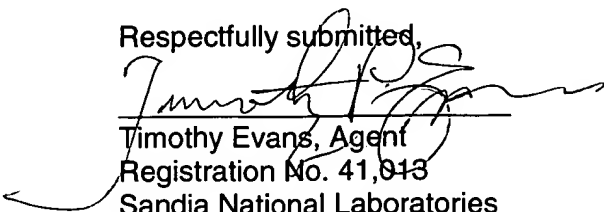
I am enclosing a copy of the Filing Receipt which was mailed from the USPTO on
February 5, 2001 and received in this office on February 13, 2001.

Please provide this office with a CORRECTED Filing Receipt.

Thank you.

Date: 2/15/01

Respectfully submitted,


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Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this Correspondence and documents referred to herein were deposited with the United States Postal Service as first class mail addressed to: Assistant Commissioner of Patents, Office of Initial Patent Examination, Customer Service Center, Washington, D. C. 20231 on the date shown below.

Date of Deposit: 2/15/01

Person making Deposit TPEvany

Serial Number: 09/712,082

Signature 
For Applicant: MESCHER, et al.



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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO.	DRAWINGS	TOT CLAIMS	IND CLAIMS
09/712,082	11/13/2000	2121	980	SD-8310	2	35	1

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FILING RECEIPT



OC000000005735929

Date Mailed: 02/05/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).**

Applicant(s) CORRECTIONS ARE HIGHLIGHTED

Mark J. Mescher, Auburndale, MA ; AUBURNDALE, MA.
Ralph B. James, Livermore, CA ;
Haim ~~Haim~~ Hermon, Jerusalem, ISRAEL ; Jerusalem

Continuing Data as Claimed by Applicant

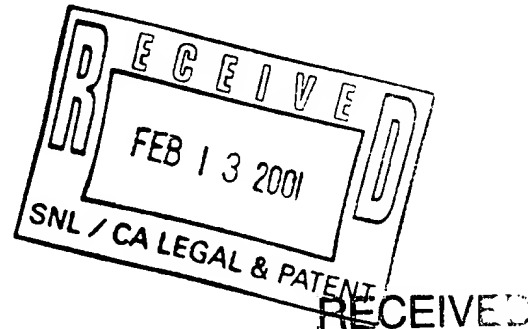
Foreign Applications

Title

Lithography process for patterning Hgl2 photonic devices

Preliminary Class

700



MAY 24 2001

Technology Center 2100

Data entry by : MONROE, BEULAH

Team : OIPE

Date: 02/05/2001

